



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov

BIB DATA SHEET

CONFIRMATION NO. 3542

SERIAL NUMBER 10/561,957	FILING or 371(c) DATE 12/22/2005 RULE	CLASS 117	GROUP ART UNIT 1791	ATTORNEY DOCKET NO. 126273		
APPLICANTS Tsuyoshi Nishizawa, Fukushima, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP04/08725 06/21/2004 ** FOREIGN APPLICATIONS ***** JAPAN 2003-182615 06/26/2003 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 06/06/2006						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No Verified and /SEYED MASOUD MALEKZADEH/ Acknowledged Examiner's Signature		<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 12	TOTAL CLAIMS 21	INDEPENDENT CLAIMS 3
ADDRESS OLIFF & BERRIDGE, PLC P.O. BOX 320850 ALEXANDRIA, VA 22320-4850 UNITED STATES						
TITLE Method for producing silicon epitaxial wafer and silicon epitaxial wafer						
FILING FEE RECEIVED 950	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		